

Obducat receives order for a EITRE® 8 NIL-system from a leading development center in China

OBDUCAT AB (publ) subsidiary Obducat Technologies AB, a leading supplier of system solutions for lithography processing, has received an order from a leading development center for acoustical applications, for the supply of a EITRE 8 system. The order value amounts to 375.000 EUR.

The EITRE 8 system will be installed in the cleanroom facilities of the development center. The system will be used for the enhancement of the application-oriented research work targeted at acoustical applications. Due to confidentiality requirements no additional information can be disclosed at this time.

The EITRE 8 system is planned to be delivered in the third quarter this year.

This is information that Obducat AB (publ.) is obliged to make public pursuant to the EU Market Abuse Regulation. The information was submitted for publication, through the agency of the contact person set out below, on April 5th, 2018 at 08.45 CET.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of companies within the LED, OLED, semiconductor, displays, biomedical and MEMS industries. Obducat's technologies include nano imprint technology, coating technology and wet processing technology. Obducat has offices in Sweden, Germany and China and the headquarter is located in Lund, Sweden. Obducat's class B shares and preferential class B shares are publicly traded on the Swedish NGM Equity stock exchange. Read more at <u>www.obducat.com</u>.